Folded Acoustic Phonon Modes in Ge/Si Quantum Dot Superlattices With Different Periods

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We present low-frequency Raman scattering measurements on self-assembled Ge/Si quantum dot superlattice samples grown by molecular beam epitaxy. The samples had different growth parameters, such as the number of periods, nominal thicknesses of Ge layers, and growth temperatures. Raman scattering peaks were observed in the low-frequency region (<30 cm−1), which were attributed to the folded acoustic phonon modes related to the periodicity of the Ge/Si quantum dot superlattices. We applied Rytov’s model to calculate the frequencies of the folded acoustic phonons in the Ge/Si quantum dot superlattices. The calculated frequencies were in good accordance with the experimental results among most of the samples. It was observed from the experiments that the Raman peak intensities decreased with the increased order of the folded acoustic phonons. Raman peak intensities from different order folded acoustic phonons were explained by photoelastic effect theory. It was also found that the intensities of Raman peaks were related to the Ge layer thickness and the periods of the Ge/Si quantum dot superlattices: the thinner the Ge layer thickness, the lower the intensity; the smaller the periods, the lower the intensity of the Raman peaks.

1. INTRODUCTION

In recent years, self-assembled Ge/Si quantum dot superlattices (QDSLs) were found to have promising applications in optoelectronics and thermoelectrics, such as photodetectors and novel thermoelectric devices etc. Towards these goals, the properties of the electrons and phonons in such kind of Ge/Si nanostructures were investigated by photoluminescence1–3 and Raman scattering4–18 techniques.

The nonresonant and resonant Raman scattering measurements in self-assembled Ge/Si QDSLs were first reported by Liu et al.4 and Kowk et al.5, respectively. Then, most of the published Raman studies on Ge/Si QDSLs were focused on the optical phonons.6, 9–14 It was demonstrated that valuable information about strain and Si/Ge interdiffusion in the QDSLs could be derived from the Ge-Ge optical phonon mode (around 300 cm−1) in the Raman spectra.9–14 Few studies on Raman scattering by acoustic phonons in self-assembled Ge/Si QDSLs were reported until Liu et al. observed a series of peaks in the range from 60 to 150 cm−1 in the Raman spectra.6 Then, several explanations were considered in Yu’s comment7 on this work and in the response of Liu et al.8. Milekhin et al. observed a series of doublet peaks below 100 cm−1 in the Raman spectra of Ge/Si QDSLs,9 which were attributed to the folded longitudinal acoustic (LA) phonons in the superlattices and explained by the Rytov’s model.19 Raman spectra of Ge/Si QDSLs in the range below 60 cm−1 have also been observed by Milekhin et al.15, Cazayous et al.,16, 17 and Tan et al.,18 in both resonant and nonresonant Raman scattering modes. However, few publications have reported on the low-frequency Raman spectra from a series of samples with different number of periods and structural data, especially in nonresonant Raman scattering mode, partly due to the fact that the signals were rather weak. In this article, we report the systematic study of the nonresonant low-frequency Raman spectra of self-assembled Ge/Si QDSLs in a series of samples with different number of periods and Ge layer thicknesses.

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2. EXPERIMENTAL

Ten samples, labeled A to J, were grown by a solid-source PerkinElmer molecular beam epitaxy (MBE) system with Stranski-Kranstanow (S-K) growth mode on Si (100) substrate. For each of the 10 samples, a 100-nm thick Si buffer layer was deposited on the substrate, followed by some identical Ge/Si bilayers to form superlattices. Each bilayer included a Ge layer and a Si spacer layer with the nominal thickness of 20 nm. No Si cap layer was used in the samples.

These 10 samples had different nominal thicknesses of Ge layers, the number of periods, and the growth temperatures. The nominal thicknesses of the Ge layer in samples A, B, and C were 0.6, 1.2, and 1.5 nm, respectively, and all three samples were of 22 periods and grown at 600°C. Samples D and E were both 10-period samples grown at 540°C, in which the nominal thicknesses of the Ge layer were 1.2 and 1.5 nm, respectively. Samples F, G, H, I, and J were grown at 540°C with the same nominally thickness 1.5-nm Ge layer and consisted of 2, 5, 20, 35, and 50 periods, respectively. The growth parameters and structural data of the 10 samples are summarized in Table 1. Raman scattering measurements were performed with a JY T64000 Raman system in backscattering configuration at room temperature. All the spectra were excited by the 514-nm line of an Ar+ laser and recorded with a liquid-nitrogen-cooled charge coupled device (CCD) camera. The spectra were obtained using the same excitation power and data accumulation time. The spectra resolution is about 0.7 cm⁻¹. The beginning frequency point of the Raman spectra is around 8 cm⁻¹.

Table 1. Growth parameters and structural data of the 10 samples.

<table>
<thead>
<tr>
<th>Sample</th>
<th>Nominal thickness of Ge layer (d₂1) (nm)</th>
<th>Nominal thickness of Si spacer layer (d₂2) (nm)</th>
<th>Growth temperature (°C)</th>
<th>Periods N</th>
</tr>
</thead>
<tbody>
<tr>
<td>A</td>
<td>0.6</td>
<td>20</td>
<td>600</td>
<td>22</td>
</tr>
<tr>
<td>B</td>
<td>1.2</td>
<td>20</td>
<td>600</td>
<td>22</td>
</tr>
<tr>
<td>C</td>
<td>1.5</td>
<td>20</td>
<td>600</td>
<td>22</td>
</tr>
<tr>
<td>D</td>
<td>1.2</td>
<td>20</td>
<td>540</td>
<td>10</td>
</tr>
<tr>
<td>E</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>10</td>
</tr>
<tr>
<td>F</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>2</td>
</tr>
<tr>
<td>G</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>5</td>
</tr>
<tr>
<td>H</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>20</td>
</tr>
<tr>
<td>I</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>35</td>
</tr>
<tr>
<td>J</td>
<td>1.5</td>
<td>20</td>
<td>540</td>
<td>50</td>
</tr>
</tbody>
</table>

3. RESULTS

Figure 1 shows the Raman spectrum of sample E. The spectrum can be distinctly divided into two regimes; one is the high-frequency region (250–550 cm⁻¹), which corresponds to the optical phonon modes in the Ge/Si QDSLs samples, and the other is the low-frequency region (<30 cm⁻¹) of acoustic modes. The Ge-Ge, Si-Ge, and Si-Si peaks located at 301, 421, and 521 cm⁻¹, respectively, are attributed to Ge, SiGe alloys, and Si substrate in the samples. The Raman peaks of the low-frequency region arise from the folded acoustic phonon (FAP) modes in the Ge/Si QDSLs. The inset of Figure 1 shows the atomic force microscopy (AFM) image of sample E. The density and average base size of the quantum dots are about 4×10⁶ cm⁻² and 0.1 μm, respectively.

Figure 2 shows the cross-sectional transmission electron microscopy (TEM) images of the 10-, 20-, and 35-period self-assembled Ge/Si QDSLs samples (i.e., samples E, H, and I). The dark lens-shaped areas, the dark stripes, and bright contrast belts in the TEM images are Ge quantum dots, Ge wetting layers, and Si spacer layers, respectively. The vertical correlations of the Ge quantum dots were clearly seen from the images. From the images, it can be observed that the actual effective thickness of Si spacer layers has shrunk to a smaller value than the nominal thickness (20 nm) since the Si spacers were deposited on the curvature surfaces of three-dimensional dots.

Figure 3a shows the Raman spectra of samples A, B, and C and an identical Si substrate. Since the nominal thickness of the Ge layer in sample A is too thin to form any Ge quantum dots, A is only a superlattice sample consisting of Ge wetting layers and Si spacer layers but without quantum dots. B and C are 22-period superlattice samples with Ge quantum dots. As seen from Figure 3a, the Raman scattering peaks can be clearly found at 16 and 15 cm⁻¹ for samples B and C, respectively, and no obvious Raman scattering peaks in sample A and Si substrate. In addition, the peak observed in sample C is stronger than that of sample B. These low-frequency Raman scattering peaks originate from the FAPs in the samples related to the periodicity of the superlattices. No low-frequency Raman scattering peak was found in the Si substrate because of its lack of periodicity. For sample A, the Ge layers in the superlattice were too thin; therefore, Raman peaks were too weak to be observed, as analyzed here.
Figure 3b shows the Raman spectra of samples D and E and an identical Si substrate. D and E are 10-period QDSL samples with different nominal thicknesses of Ge layers. Three obvious Raman peaks were found in both samples D and E, locating at 11, 19, and 25 cm⁻¹ and 11, 20, and 25 cm⁻¹, respectively. The Raman peaks of sample E are relatively stronger than those of sample D. The three peaks of both samples decreased step by step from low to high frequency.

Figure 4 shows the low-frequency Raman scattering spectra of a series of samples, F to J, that have the same nominal thickness of Ge layers but a different number of superlattice periods. The Raman scattering spectrum of an identical Si substrate is also shown. Samples F, G, H, I, and J have 2, 5, 20, 35, and 50 periods of Ge/Si bilayers, respectively. From Figure 4, three Raman peaks were found in samples H, I, and J, and only one peak was observed in sample G. The peak positions are presented in the left half of Table 2. No peak was seen from sample F and Si substrate. It was found that the intensities of the Raman peaks increased with the number of the periods of superlattices. Sample F has just 2 periods; the Raman peaks are too weak to be observed. Sample G has 5 periods, and only one peak was found. The intensities of Raman scattering peaks from samples H, I, and J increased with their superlattice periods, and the three Raman peaks in each of the samples decreased with the FAPs’ incremental order.

The inset of Figure 4 shows the relations between the normalized Raman intensities and number of superlattice periods of samples H, I, and J from three different orders. In the graph, Raman peak intensity of first-order FAPs in sample J was taken as unit, and all other peak intensities were normalized by this value. Nonresonant Raman
Table 2. Experimental and calculated Raman frequencies of the first four orders of FAPs.

<table>
<thead>
<tr>
<th>Sample</th>
<th>Experimental FAP Frequencies $\omega_{\text{exp}}$ (cm$^{-1}$)</th>
<th>Calculated FAP Frequencies $\omega_{\text{cal}}$ (cm$^{-1}$)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>$n=0$ 1 2 3</td>
<td>$m=0$ 1+ 2+</td>
</tr>
<tr>
<td>A</td>
<td>—      —      —      —      4.4 11.8 20.7 28.1</td>
<td>4.4 11.2 20.0 26.8</td>
</tr>
<tr>
<td>B</td>
<td>—      —      16.1    —      4.4 11.2 20.0 26.8</td>
<td></td>
</tr>
<tr>
<td>C</td>
<td>—      —      15.4    —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>D</td>
<td>10.7   18.8 24.8      —      4.4 11.2 20.0 26.8</td>
<td></td>
</tr>
<tr>
<td>E</td>
<td>11.5   19.6 25.0      —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>F</td>
<td>—      —      —      —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>G</td>
<td>—      —      17.4    —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>H</td>
<td>—      11.4   18.8 26.2      —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>I</td>
<td>—      10.7   18.8 24.8      —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
<tr>
<td>J</td>
<td>—      11.4   19.5 24.8      —      4.4 10.9 19.6 26.1</td>
<td></td>
</tr>
</tbody>
</table>

The reason for these low-frequency periodic acoustic phonon modes is the superlattice samples with more periods have correspondingly larger Raman intensities, which was in accordance with the experimental results. Our experimental results showed that the intensities appear in an exponential relation with the superlattice periods. Some interesting theoretical works on how the Raman scattering spectra of the Ge QDSLs depend on the quantum dot sizes and the number of quantum dot layers have already been reported by Cazayous et al., but there were few detailed experimental reports on several kinds of Ge/Si QDSLs samples with superlattice period number and structural data before our work, especially the experiments in nonresonant Raman scattering mode.

4. DISCUSSION

The reason for these low-frequency periodic acoustic phonon peaks is associated with a superlattice for which low-frequency zone-edge phonon modes have been folded into the zone center rather than phonon confinement in quantum dots. Rylov’s elastic continuum model has been applied to explain the experimental results, in which the acoustic phonon dispersions of Ge/Si QDSLs were written as

$$\cos(qd) = \cos\left(\frac{\omega d_1}{V_1}\right) \cos\left(\frac{\omega d_2}{V_2}\right) - k^2 + \frac{1}{2k} \sin\left(\frac{\omega d_1}{V_1}\right) \sin\left(\frac{\omega d_2}{V_2}\right)$$

where $d_1$ and $d_2$, $V_1$ and $V_2$, $\rho_1$ and $\rho_2$ are thicknesses, sound velocities, and densities of the Si spacer and Ge layers, respectively; $q$ is the superlattice wave vector; $d = d_1 + d_2$ is the superlattice period; and $k = V_1 \rho_1 / (V_2 \rho_2)$ is a ratio coefficient. For large $d$ and frequencies less than 100 cm$^{-1}$, the dispersion is assumed to be linear, and the FAP dispersion can be approximately simplified as

$$\omega = \frac{1}{2\nu c} \left(\frac{2\pi m \pm q}{d}\right) V_s$$

where $c$ is the speed of light; $m = 0, 1, 2, \ldots$ is the folding index of the FAPs; and $V_s$ is the acoustic velocity in the superlattice, which is given in Rylov’s theory as

$$V_s = d \left(\frac{d_1^2}{V_1^2} + \frac{d_2^2}{V_2^2} + \left(\frac{k+1}{k}\right) \frac{d_1 d_2}{V_1 V_2}\right)^{-1/2}$$

The scattering wave vector $q_s$ in the backscattering geometry can be roughly determined as

$$q_s \approx \frac{4\eta(\lambda)\pi}{\lambda} \left(1 - \frac{1}{4\eta^2(\lambda)}\right)$$

with $\lambda$ and $\eta(\lambda)$ the incident laser light wavelength and the refractive index of the material at that wavelength, respectively. We approximately consider the refractive indexes of both Si and Ge as $\eta = \pm 4.2$ for $\lambda = 514$ nm. Thus, we employ this value throughout the superlattices (i.e., for both Ge layers and Si spacer layers).

The densities of Si and Ge are 2.3 and 5.3 g/cm$^3$, respectively, and the sound velocities in pure Si and Ge layers are 8.4 and 4.9 km/s, respectively. For the Si spacer layers composed of pure Si, the density and sound velocity were directly employed with values of Si, that is, $\rho_1 = \rho(\text{Si}) = 2.3$ g/cm$^3$, and $V_1 = 8.4$ km/s. In the Ge layers of Ge/Si QDSLs samples, however, the Ge quantum dots and wetting layers are not pure Ge but the alloy of Ge and Si due to the Si/Ge interdiffusion during the growth. The composition of Ge can be estimated from the intensity ratio among the Raman peaks in the optical region. The Ge compositions of the quantum dots were calculated as around 50% in our samples. Then, the sound velocity in Ge layers can be obtained by the linear interpolation of sound velocity of pure Si and Ge. We assumed the density and sound velocity of Ge layers as following: $\rho_2 = [\rho(\text{Si}) + \rho(\text{Ge})]/2 = 3.8$ g/cm$^3$, and $V_2 = [V(\text{Si}) + V(\text{Ge})]/2 = 6.7$ km/s.

The designed thickness of the Si spacer layer for all the samples was 20 nm. But, as described, the actual thicknesses of the Si spacer layers were shrunken due to the existence of Ge quantum dots. For different samples, the shrunken values were slightly different as characterized by cross-sectional TEM images. We employed an approximately general value $d_1 = 16.5$ nm for all the Si spacers in the following calculations. In addition, we took the nominal thicknesses of the Ge layers as values of $d_2$, which was also employed in Refs. 9 and 15. The $d_2$ values of different samples are listed in Table 1.

Figure 5b shows the calculated dispersions of FAPs in sample E. The vertical dashed line in Figure 5b stands for the scattering wave vector in the experiments. The three
intersections between the solid FAP dispersion curve and the dashed line are the frequencies of FAPs with three different orders. The frequencies of the FAPs are in good accordance with the experimental results. The calculated frequencies of the FAPs for all the samples are listed in the right half of Table 2. The calculated zero-order FAP was not observed in the experiments due to the relatively high initial point frequency (8 cm⁻¹) in the Raman spectra. The FAPs from first to third order observed in the experiments (listed in the left side of Table 2) agree with the calculations. The FAPs above fourth order were not observed in our experiments due to the relatively low intensities compared with the previous orders.

The Raman intensity \( I_n \) of the \( n \)-th order FAPs can be estimated based on photoelastic effect as

\[
I_n \propto \frac{\sin^2(n\pi d_2/d)}{n^2} [\omega_n(b_n + 1)]
\]

where \( \omega_n \) is the frequency of \( n \)-th order FAPs in the Ge/Si QDSLs, and \( b_n \) is their Bose factor. The Raman spectra of samples D and E shown in Figure 3b show that sample E has a relatively higher Raman intensity than sample D. This can be roughly explained by Eq. (5). Since sample E has a larger \( d_2 \) value (1.5 nm) than that of sample D (1.2 nm), it has a relatively larger Raman intensity for the same order FAPs. The peak intensity difference between samples C and B can also be explained in the same way. In the same sample, the intensities of FAP peaks decreased with the increase of the order. This is also in accordance with the theory [Eq. (5)]. We fitted the relation of peak intensities and orders using square \( \text{Sinc}(n) \) functions, which were shown as solid lines in Figure 6. The symbols in Figure 6 are the experimental results of Raman peak intensities from the first three order FAPs in different samples, which were normalized by the first-order peak intensities of sample E in Figure 6a and J in Figure 6b, respectively. The trend of the symbols follows the solid lines well.

5. CONCLUSIONS

In summary, we have reported the low-frequency Raman scattering spectra of self-assembled Ge/Si QDSLs. Low-frequency Raman scattering peaks arose from the FAPs in the Ge/Si QDSLs. Rytov’s model was applied to calculate the frequencies of the FAPs in the Ge/Si QDSLs. The calculated frequencies were in good accordance with the experimental results among most of the samples. The Raman peak intensities decreased with the increasing order of FAPs. Raman peak intensities from different order FAPs have been fitted, and the intensities of the Raman peaks were related to the Ge layer thickness and the periods of the Ge/Si QDSLs: the thinner the Ge layer thickness, the lower the intensity; the smaller the periods, the lower the intensity of the Raman peaks.

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References